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CONFIRMATION NO. 4111

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/577,069	06/20/2006	257	2891	7372/88130		
RULE						
APPLICANTS Masahiko Hata, Tsuchiura-shi, JAPAN; Yoshinobu Ono, Tsukuba-gun, JAPAN; Kazumasa Ueda, Tsuchiura-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/16186 10/25/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-365736 10/27/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/29/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/JULIA SLUTSKER/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 6	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 2
ADDRESS FITCH, EVEN, TABIN & FLANNERY P. O. BOX 18415 WASHINGTON, DC 20036 UNITED STATES						
TITLE Method for manufacturing compound semiconductor substrate						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		